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PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

n re application of

Docket No: Q61721

Tsuyoshi KITAHARA

Appln. No.: 09/708,514

Group Art Unit: 2861

Confirmation No.: 1708

Examiner: Judy NGUYEN

Filed: November 9, 2000

For: INK-JET RECORDING HEAD AND METHOD OF MANUFACTURING THE SAME

STATEMENT OF SUBSTANCE OF INTERVIEW

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Sir:

Please review and enter the following remarks summarizing the interview conducted on January 27, 2004:

REMARKS

An Examiner's Interview Summary Record (PTO-413) was attached with the Office communication dated January 30, 2004.

During the interview, pending base claims (specifically Claim 1) and their differences with Nakamura (JP 08-187868) were discussed. The Applicants noted that an etched land, etched partition wall, etc., were structural limitations (an not method steps) that should be given patentable weight in an apparatus claim. Though the Examiner incorrectly notes to the contrary in the interview summary, no agreement was reached on the status of the claims.

It is believed that no petition or fee is required. However, if the USPTO deems otherwise, Applicant hereby petitions for any extension of time which may be required to

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maintain the pendency of this case, and any required fee, except for the Issue Fee, for such extension is to be charged to Deposit Account No. 19-4880.

Respectfully submitted,

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Date: February 26, 2004